6 degrees of freedom actuator for microlens arrays Prof. Marc Desmulliez

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Abstract not available

Prof. Marc Desmulliez was born in 1963 in France and holds 4 Engineering and Physics degrees (Paris, Cambridge, UCL and Heriot-Watt). After a couple of years working in industry as an electrical power engineer, he founded the Microsystems Engineering Centre (MISEC), arguably the 4th largest UK research MEMS research group. MISEC specializes in non-silicon MEMS, RF-MEMS, Health and Usage Monitoring Microsystems, Advanced Manufacturing Technologies, LTCC and optoelectronics. Prof. Desmulliez co-authors over 280 publications and currently holds 7 patents in these fields. He founded MicroStencil Ltd, a company currently trading in Singapore and specializing in the manufacturing of electroformed state of the art stencils for the microelectronics and PV industries. He is currently a Reviewer for the European Research Council and one of the two UK-members of the Steering committee of the European technology Platform EPoSS (European Platform in Smart Systems integration).